

Application No. 10/674,372
Amendment filed: November 14, 2005
Reply to Office Action of July 12, 2005

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Attorney's Docket No.: 042390.P15995

Patent

IN THE UNITED STATES PATENT AND TRADEMARK OFFICE

In Re Application of:

Frederick Haubensak

Application No.: 10/674,372

Filed: September 29, 2003

For: WAFER DEFECT REDUCTION BY
SHORT PULSE LASER ABLATION

Examiner: Elve, Maria Alexandra

Art Unit: 1725

Mail Stop Amendment
Commissioner for Patents
P.O. Box 1450
Alexandria, VA 22313-1450

AMENDMENT AND RESPONSE

Dear Sir:

This is in response to the Office Action mailed July 12, 2005. Applicant respectfully requests the Examiner to consider the following remarks.

FIRST CLASS CERTIFICATE OF MAILING

I hereby certify that this correspondence is being deposited with the United States Postal Service as first class mail with sufficient postage in an envelope addressed to Mail Stop Amendment, Commissioner for Patents, P.O. Box 1450, Alexandria, VA 22313-1450 on

November 14, 2005

Date of Deposit

Vanessa Sanchez

Name of Person Mailing Correspondence

Vanessa Sanchez
Signature

11/14/05
Date

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